

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Takashi IZUTA

Serial No.: 10/806,844

Filed: March 22, 2004

Confirmation No.: 2467

Date: April 6, 2007

Group Art Unit: 1763

Examiner: Rakesh Kumar Dhingra

For: SUBSTRATE TREATING METHOD AND APPARATUS

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VIA EFS-WEB

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

PETITION AND FEE FOR AUTOMATIC EXTENSION OF TIME  
UNDER 37 CFR 1.17, 1.136(a) AND 35 USC 41(a)8

Sir:

Applicant hereby petitions the Commissioner for Patents to extend the time for filing a response to the outstanding Office Action by One (1) month. Credit card payment for the required filing fee of \$120.00 is being submitted via EFS-WEB for the petition fee in accordance with 37 CFR 1.17 computed as:

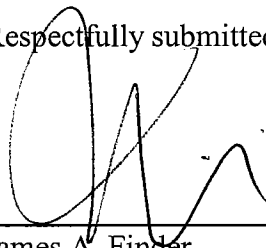
X Response within first month  
X not small entity (\$120)

You are authorized to charge to our Deposit Account No. 15-0700 any additional amounts owing.

If this petition is inadequate to avoid abandonment, the Assistant Commissioner for Patents is petitioned, under 37 C.F.R. §1.136(a), to extend the time by the number of months which will avoid abandonment under 37 C.F.R. §1.135. The fee under 37 C.F.R. § 1.17 should be charged to our Deposit Account No. 15-0700.

THIS CORRESPONDENCE IS BEING  
SUBMITTED ELECTRONICALLY  
THROUGH THE PATENT AND  
TRADEMARK OFFICE EFS FILING  
SYSTEM ON April 6, 2007.

Respectfully submitted,



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